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Application No. 09/692,211
Docket No. 740819-442

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Akihiko ISHIBASHI et al.

Serial No. 09/692,211

Filed: 10/20/2000

For: METHOD OF FABRICATING NITRIDE
SEMICONDUCTOR DEVICE

Examiner: S. Mulpuri
Group Art Unit: 2812

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231, on

Jul. S.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

The enclosed references were cited in a Notice of Reasons for Rejection on May 23, 2002.

It is requested that the accompanying information disclosure statement be considered and made of record in the above-captioned application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

JP 2702889 corresponds to JP 07-235505. US 5,757,104 corresponds to 08-255932, and EP 0 887 436 corresponds to JP 11-074203.

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The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By: _____

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